



THE UNIVERSITY OF ARIZONA

James C. Wyant
College of Optical Sciences

Nanofabrication Facility

Costs for Internal Users Only

- **Service Rate #1 *\$30/hour includes the use of wet benches, oven, hot plates, spinners, UV Curing and all equipment located within rooms 712, 712A, 712C, and 712C2 (with the exception of the EBL System), 867, 857A, and 857B**
- **Service Rate #2 *\$101/hour is an additional fee for the usage of the Elionix Model ELS-7000 100 kV Electron Beam Lithography System (fabrication and Imaging-including set-up/take down time)**
- **Service Rate #3 \$2/nm (gold), only applies to Temescal evaporator**

*Rate will be prorated to 15 minute increments. For Service Rate #2, the base Service rate #1 will be waived if user certifies in writing they were exclusively in cleanroom utilizing EBL System and nothing else; a note will be required on login book.

All users are required to complete mandatory chemical training before they are granted access to ensure user safety and compliance with UA Research Laboratory & Safety Services (RLSS).

Questions related to OSC Nanofabrication Facility should be directed to the Roland Himmelhuber, Nanofabrication Facility Manager at rolandh@optics.arizona.edu or voicemail (520) 626-9041.